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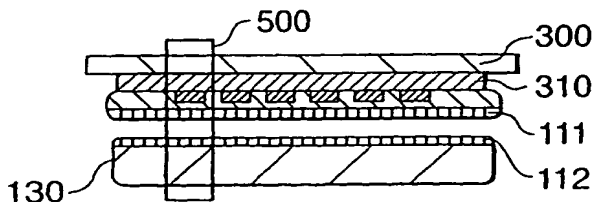
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(54) **Thin-film semiconductor device and method of manufacturing the same**

(57) A thin-film semiconductor device with a reduced influence on a device formation layer in separation and a method of manufacturing the device are provided. The manufacturing method includes the step of preparing a member having a semiconductor film with a

semiconductor element and/or semiconductor integrated circuit on a separation layer, the separation step of separating the member at the separation layer by a pressure of a fluid, and the chip forming step of, after the separation step, forming the semiconductor film into chips.

FIG. 1C



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FIG. 1D

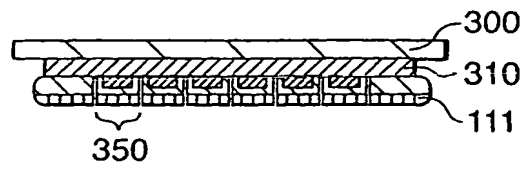
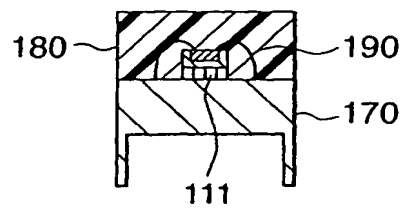


FIG. 1E



FIG. 1F





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Application Number
EP 02 00 2259

DOCUMENTS CONSIDERED TO BE RELEVANT			
Category	Citation of document with indication, where appropriate, of relevant passages	Relevant to claim	CLASSIFICATION OF THE APPLICATION (Int.Cl.7)
X	WO 00/63965 A (SILICON GENESIS CORPORATION; KANG, SIEN, G; MALIK, IGOR, J) 26 October 2000 (2000-10-26) * page 1, line 18 - page 2, line 28; figures 1,6,6a,17a-17c * * page 6, line 18 - page 9, line 11 * * page 12, line 10 - page 12, line 25 *	1-9,11	H01L21/78 H01L21/762
X	FR 2 784 794 A (COMMISSARIAT A L'ENERGIE ATOMIQUE) 21 April 2000 (2000-04-21) * page 12, line 12 - page 13, line 11; figures 4-7 *	10,12	
X	US 6 010 579 A (HENLEY ET AL) 4 January 2000 (2000-01-04) * column 4, line 1 - column 6, line 51; figures 1-3,10-16 *	1-9,11	
X	US 6 171 965 B1 (KANG SIEN G ET AL) 9 January 2001 (2001-01-09) * the whole document *	1-9,11	
A	US 5 071 792 A (VANVONNO ET AL) 10 December 1991 (1991-12-10) * abstract; figures 3,15-17 *	1,10-12	H01L
The present search report has been drawn up for all claims			TECHNICAL FIELDS SEARCHED (Int.Cl.7)
Place of search The Hague		Date of completion of the search 25 August 2005	Examiner Hedouin, M
<p>CATEGORY OF CITED DOCUMENTS</p> <p>X : particularly relevant if taken alone Y : particularly relevant if combined with another document of the same category A : technological background O : non-written disclosure P : intermediate document</p> <p>T : theory or principle underlying the invention E : earlier patent document, but published on, or after the filing date D : document cited in the application L : document cited for other reasons & : member of the same patent family, corresponding document</p>			

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EPO FORM 1503 03.02 (P4/C01)

**ANNEX TO THE EUROPEAN SEARCH REPORT
ON EUROPEAN PATENT APPLICATION NO.**

EP 02 00 2259

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25-08-2005

Patent document cited in search report		Publication date	Patent family member(s)	Publication date
WO 0063965	A	26-10-2000	US 6171965 B1	09-01-2001
			US 6204151 B1	20-03-2001
			US 6391219 B1	21-05-2002
			AU 4481100 A	02-11-2000
			WO 0063965 A1	26-10-2000
			US 2003008477 A1	09-01-2003
			US 2001016402 A1	23-08-2001
FR 2784794	A	21-04-2000	FR 2784794 A1	21-04-2000
			WO 0024054 A1	27-04-2000
US 6010579	A	04-01-2000	AU 7685198 A	08-12-1998
			CA 2290104 A1	19-11-1998
			CN 1255237 A ,C	31-05-2000
			EP 0995227 A1	26-04-2000
			JP 2001525991 T	11-12-2001
			US 2002055266 A1	09-05-2002
			US 6048411 A	11-04-2000
			US 6159824 A	12-12-2000
			US 5985742 A	16-11-1999
			US 5994207 A	30-11-1999
			US 6146979 A	14-11-2000
			US 6013563 A	11-01-2000
			US 6159825 A	12-12-2000
			US 6155909 A	05-12-2000
			US 6245161 B1	12-06-2001
			US 6162705 A	19-12-2000
			US 6290804 B1	18-09-2001
			US 2002081823 A1	27-06-2002
			WO 9852216 A1	19-11-1998
			US 2003113983 A1	19-06-2003
			US 6391740 B1	21-05-2002
			US 6013567 A	11-01-2000
			US 6511899 B1	28-01-2003
			US 6291313 B1	18-09-2001
			US 6413837 B1	02-07-2002
			US 6528391 B1	04-03-2003
			US 6187110 B1	13-02-2001
			US 6033974 A	07-03-2000
			US 6294814 B1	25-09-2001
			US 6284631 B1	04-09-2001
			US 2002106870 A1	08-08-2002
			US 6558802 B1	06-05-2003
			US 6335264 B1	01-01-2002
			US 6458672 B1	01-10-2002
			US 2001026997 A1	04-10-2001

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**ANNEX TO THE EUROPEAN SEARCH REPORT
ON EUROPEAN PATENT APPLICATION NO.**

EP 02 00 2259

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The European Patent Office is in no way liable for these particulars which are merely given for the purpose of information.

25-08-2005

Patent document cited in search report	Publication date	Patent family member(s)	Publication date
US 6010579	A	US 2002115264 A1	22-08-2002
		US 2002056519 A1	16-05-2002
		US 2005070071 A1	31-03-2005
US 6171965	B1	09-01-2001	
		AU 4481100 A	02-11-2000
		WO 0063965 A1	26-10-2000
US 5071792	A	10-12-1991	
		EP 0537306 A1	21-04-1993
		WO 9209098 A2	29-05-1992
		US 5185292 A	09-02-1993

EPO FORM P0459

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